

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/565,767 Confirmation No. 2990
Applicant : Yuichiro Shindo
371 Filed : January 24, 2006
Art Unit : 1793
Examiner : Mark L. Shevin
Customer No. : 00270
Title : HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN
FILM COMPRISING THE SAME, AND METHOD FOR
PRODUCING HIGHLY PURE HAFNIUM

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a Response being submitted with a Request for Continued Examination (RCE) in reply to a FINAL Office Action dated November 20, 2009. A Petition for a Two Month Extension of Time is filed herewith to extend the deadline for response from February 20, 2010 to April 20, 2010.

Remarks/Arguments begin on page 2 of this paper.